



Sheet 1 of 1

FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTORNEY DOCKET NO.	APPLICATION NO.
			1572.1243	10/820,748
INFORMATION DISCLOSURE STATEMENT <i>(Use several sheets if necessary)</i>			FIRST NAMED INVENTOR	
			Je-Hyoung RYU, et al.	
			FILING DATE	GROUP ART UNIT
			April 9, 2004	2829

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
VN	AA	5,744,863	4/28/98	Culnane et al.			
	AB						
	AC						
	AD						
	AE						
	AF						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	TRANSLATION YES    NO	ENGLISH ABSTRACT
VN	AG	2002-0087227	11/22/02	Republic of Korea	X	X
VN	AH	2002-0078718	10/19/02	Republic of Korea	X	X
VN	AI	2000-0052405	8/25/00	Republic of Korea	X	X
VN	AJ	1999-000619	01/15/99	Republic of Korea	X	
VN	AK	2002-0061468	07/24/02	Republic of Korea	X	
	AL					

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

TRANSLATION YES    NO

	AM		
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## EXAMINER

## DATE CONSIDERED

08/26/05

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.


**ATTACHMENT 1(g)**

<b>LIST OF ADDITIONAL SUBMITTED DOCUMENTS</b>	ATTORNEY DOCKET NO.	APPLICATION NO.
	1572.1243	10/820,748
	FIRST NAMED INVENTOR	
	Je-Hyoung RYU, et al.	

FILING DATE GROUP ART UNIT

April 9, 2004 2829

The following document(s) is/are listed in accordance with the duty of disclosure provisions of 37 CFR § 1.56, so that the Examiner may consider same should he deem any thereof to be material to examination of the subject application.

It is requested that the Examiner acknowledge his consideration of document(s) below-listed by initialling same in the space provided adjacent each such application and that the Examiner sign and date this form at the bottom thereof to confirm such consideration having been given.

This submission in no way represents an admission that any of the information listed herein constitutes prior art with respect to the subject application; and unless and until such prior art status is established, this submission is not a request that the information presented herein be printed on the face of any patent issuing from the subject application in which this information is being filed.

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
	AA						
	AB						

**FOREIGN PATENT DOCUMENTS**

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO
	AC						
	AD						

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

TRANSLATION YES	NO
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VN	AE	Korean Office Action issued on July 12, 2005		X
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EXAMINER <i>anh Nguyen</i>	DATE CONSIDERED <i>08/26/05</i>
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\*EXAMINER: Initial if document considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ATTACHMENT 1(e)

<b>EXPLANATIONS OF RELEVANCY OF REFERENCES</b>	ATTORNEY DOCKET NO.	APPLICATION NO.
	1572.1243	10/890 748
	FIRST NAMED INVENTOR	
	Je-Hyoung RYU, et al.	
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Reference AG (KR 1999-619) is entitled "Preventing Heating Up of Semiconductor Tester."

Reference AH (KR 2002-61468) is entitled "Contractor of the Device for Testing Semiconductor Element."



08/26/05